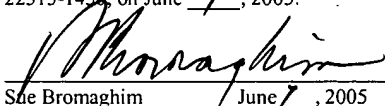


Certified Mailing Under 37 CFR 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on June 7, 2005.


Sue Bromaghin June 7, 2005

CUSTOMER NO. 36256

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Wayne Glenn RENKEN et al.
Title: Integrated Process Condition Sensing Wafer and Data Analysis System
Application No.: 10/718,269 Filing Date: November 19, 2003
Examiner: Jermele M. HOLLINGTON Group Art Unit: 2829
Docket No.: SENS.008US3 Conf. No.: 9982

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Pursuant to 37 C.F.R. §§ 1.56, 1.97 and 1.98, Applicant(s) call(s) the documents listed on the enclosed Form PTO-1449 to the Examiner's attention in this patent application.

- ☒ According to 37 C.F.R. 1.98(2)(ii), copies of the U.S. Patents and U.S. Published Patent Applications documents are not required and are therefore not enclosed. Copies of the Other Art are enclosed.

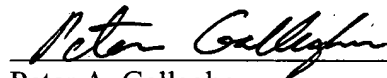
Attorney Docket No. SENS.008US

Application No. 10/718,269

Citation of these documents shall not be construed as (1) an admission that the documents are prior art with respect to the invention or inventions claimed in this application, (2) a representation that a search has been made (other than as indicated by any cited document), or (3) an admission that the cited information is, or is considered to be, material to patentability as defined in § 1.56(b).

This information disclosure statement is submitted under 37 C.F.R. § 1.97(b) and consequently no fee should be required. The Commissioner is authorized, however, to charge any fee that may be required, or to credit any overpayment, against Deposit Account No. 502664. This form is being submitted in duplicate.

Respectfully submitted,



Peter A. Gallagher
Reg. No. 47,584

June 7, 2005
Date

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U.S. Department of Commerce, Patent and Trademark	Atty. Docket No.	Application No.
INFORMATION DISCLOSURE STATEMENT BY APPLICANT	SENS.008US3	10/718,269
(Use several sheets if necessary)	Applicant(s)	Conf. No.
(Form PTO-1449)	Wayne Glenn RENKEN et al.	9982
	Filing Date	Group
	November 19, 2003	2829

U.S. Patent Documents

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	1	6,691,068 B1	02/10/2004	FREED et al.	702	187	

U.S. Published Patent Application Documents

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	2	2003/0223057 A1	12/04/2003	RAMSEY et al.	356	147	
	3	2004/0267501 A1	12/30/2004	FREED et al.	702	184	

Foreign Patent Documents

							Translation	
		Document	Date	Country	Class	Subclass	Yes	No

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

	4	US PROVISIONAL APPLN. 60/354,551, filed 02/06/2002, to RAMSEY et al., entitled "Wafer-Like Sensor".
	5	US PROVISIONAL APPLN. 60/525,710, filed 11/29/2003, to MUNDT et al., entitled "Sensor Apparatus Automated Management Methods and Apparatus".
	6	INTERNATIONAL PRELIMINARY EXAMINATION REPORT from corresponding Appln. No. PCT/US03/37836, dated October 7, 2004 (7 pages).

Examiner	Date Considered
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.